. '	Application No.	Applicant(s)		
Notice of Allowability	09/894,460	DONOHOE, KEVIN G.		
	Examiner	Art Unit		
	Igwe U. Anya	2829	· · · · · · · · · · · · · · · · · · ·	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.				
1. This communication is responsive to <u>11/23/04</u> .				
2. The allowed claim(s) is/are 1-56.				
3. The drawings filed on <u>28 June 2001</u> are accepted by the Ex	xaminer.			
 4. Acknowledgment is made of a claim for foreign priority uner a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 				
2. Certified copies of the priority documents have	been received in Application No	·	1	
3. Copies of the certified copies of the priority documents have been received in this national stage application from the				
International Bureau (PCT Rule 17.2(a)).			• * * •.	
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	ENT of this application.			
5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER' es reason(s) why the oath or declarat	S AMENDMENT or NOT tion is deficient.	ICE OF	
6. \square CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.			
(a) \square including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-9	948) attached		
1) ☐ hereto or 2) ☐ to Paper No./Mail Date				
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment or in the O	ffice action of		
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the drawin ne header according to 37 CFR 1.121(d	gs in the front (not the ba l).	ck) of	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT R	sit of BIOLOGICAL MATERIAL m FOR THE DEPOSIT OF BIOLOGICA	nust be submitted. Note	e the	
Attachment(s)			•	
1. Notice of References Cited (PTO-892)	5. Notice of Informal Pa	atent Application (PTO-1	52)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. 🔲 Interviéw Summary ((PTO-413),	- - /	
3. A Information Disclosure Statements (PTO-1449 or PTO/SB/08	Paper No./Mail Date 8), 7. ☐ Examiner's Amendm	Paper No./Mail Date 7.		
Paper No./Mail Date <u>11/23/04</u> 4. ☐ Examiner's Comment Regarding Requirement for Deposit	8. X Examiner's Statement	nt of Reasons for Allowa	nce	
of Biological Material	9. 🗌 Other			
			•	

Application/Control Number: 09/894,460 Page 2

Art Unit: 2829

REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance. Applicant's IDS filled on November 23, 2004 has been considered, and do not read on the pending claims. Allowance of pending claims is maintained as per previous reasons, herein restated. A method of forming an aperture in silicon oxide, comprising, inter alia:

(claims 1, 17, 20, 25, 28, 29, 37, 39) aspect ratio of 5:1 or greater using bromine, iodine, bromine-containing, or iodine-containing gas to advance an etch front in silicon oxide aperture;

(claim 19) sidewall taper angle of 87 degrees or more using iodine-containing plasma; and.

(claims 41, 49, 53) etching the silicon oxide with a fluorocarbon gas, forming polymer residue on sidewalls of the aperture, advancing the etch front by adding bromine, iodine, bromine-containing, or iodine-containing gas to passivate the polymer residue until a desired aspect ratio is attained.

2. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Contact Information

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Igwe U. Anya whose telephone number is (571) 272-1887. The examiner can normally be reached on M - F 8:30am - 5:00pm.

Application/Control Number: 09/894,460

Art Unit: 2829

Page 3

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, William B. Baumeister can be reached on (571) 272-1722. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Igwe U. Anya Examiner Art Unit 2829

IA

February 14, 2005

B. WILLIAM BAUMEISTER

PRIMARY EXAMINER